

Title (en)

Baking oven with bottom heat and hot air

Title (de)

Backofen mit Unterhitze und Heißluft

Title (fr)

Four de cuisson avec chauffage de la sole et de l'air chaud

Publication

**EP 2610557 A1 20130703 (DE)**

Application

**EP 12008153 A 20121206**

Priority

CH 20502011 A 20111227

Abstract (en)

The oven has muffle (1) and bottom heater (4). The heater is provided to heat the muffle from downside. The lateral ventilation opening is provided at side wall of muffle. An air conveyor (10) is provided in thermal contact with heater to convey the hot air from lateral ventilation opening through channel (8) which is arranged below the muffle.

Abstract (de)

Um in einem Backofen einen Heissluftstrom zu erzeugen, ist im thermischen Kontakt mit der Unterhitze (4) ein Kanal (8) vorgesehen, durch welchen Luft gefördert werden kann. Hierdurch entfällt eine separate, für Heissluft-Backöfen übliche Kammer an der Rückseite der Muffel (1).

IPC 8 full level

**F24C 15/32** (2006.01)

CPC (source: EP)

**F24C 15/32** (2013.01); **F24C 15/325** (2013.01)

Citation (search report)

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- [X] GB 2256041 A 19921125 - BINDER WTB LABORTECH GMBH [DE]
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Designated contracting state (EPC)

AL AT BE BG CH CY CZ DE DK EE ES FI FR GB GR HR HU IE IS IT LI LT LU LV MC MK MT NL NO PL PT RO RS SE SI SK SM TR

Designated extension state (EPC)

BA ME

DOCDB simple family (publication)

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DOCDB simple family (application)

**CH 20502011 A 20111227;** EP 12008153 A 20121206